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<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. <b>FIS920030091US1</b>
Application No. <b>10/604,146</b>	Filing Date <b>06/27/03</b>	Examiner <b>Jack S. J. Chen</b>	Art Unit <b>2813</b>

Applicant(s): **Joel P. DeSouza et al.**

Invention: **SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE IMPLANT AND ROOM TEMPERATURE IMPLANT**

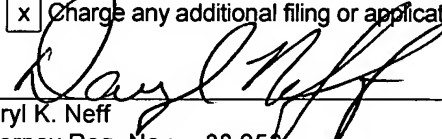
**TO THE COMMISSIONER FOR PATENTS**

Transmitted herewith is an amendment in the above-identified application.

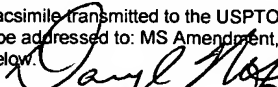
The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	<b>10</b>	<b>20</b>	<b>0</b>		
Independent Claims	<b>1</b>	<b>- 3</b>	<b>0</b>		
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					

- ☒ Large Entity ☐ Small Entity
- ☒ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **09-0458** as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
Daryl K. Neff  
Attorney Reg. No.: **38,258**

Dated: **May 9, 2005**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.  
Dated: May 9, 2005 Signature:  (Daryl K. Neff)



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Name of Depositor: Daryl K. Neff

Signature

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: <b>Joel P. DeSouza et al.</b>	Date: <b>May 9, 2005</b>
Serial Number: <b>10/604,146</b>	Examiner: <b>Jack S. J. Chen</b>
Filed: <b>June 27, 2003</b>	Group Art Unit: <b>2813</b>
Title: <b>SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE IMPLANT AND ROOM TEMPERATURE IMPLANT(Amended)</b>	H. Daniel Schnurmann IBM Corporation Dept. 18G, B/321, Zip 482 2070 Route 52 Hopewell Junction, NY 12533

**AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 8, 2005, Applicants submit the following amendments and remarks for the Examiner's consideration.

**Title of the Invention**

Please amend the Title to read:

SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE  
IMPLANT AND ROOM TEMPERATURE IMPLANT